

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Walter SCHWARZENBACH *et al.* Confirmation No.:
Application No.: Group Art Unit:
Filing Date: Concurrently herewith Examiner:
For: ANNEALING PROCESS AND DEVICE OF Attorney Docket No.: 4717-7700
SEMICONDUCTOR WAFER

INFORMATION DISCLOSURE STATEMENT

Mail Stop PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56, listed on the enclosed Form PTO-1449 are thirty-eight (38) references for the Examiner's review. Copies of references B1-B5 and C1 are enclosed. Copies of references A1-A32 will be provided at the Examiner's request. Also enclosed is a copy of the French Preliminary Search Report from the priority application.

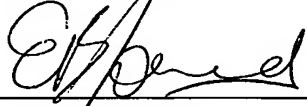
It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the attached Form PTO-1449.

No fee is believed to be due for the submission of the these references. Should any fees be required, however, please charge such fees to Winston & Strawn Deposit Account No. 50-1814.

Respectfully submitted,

Nov. 20, 2003

Date



E. Bradley Gould (Reg. No. 41,792)
For: Allan A. Fanucci (Reg. No. 30,256)

WINSTON & STRAWN
Customer No. 28765

202-371-5771

LIST OF REFERENCES CITED BY APPLICANT Form PTO-1449 <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.:	APPLICATION NO.:
	4717-7700 APPLICANT: Walter SCHWARZENBACH <i>et al.</i>	
Sheet 1 of 2	FILING DATE: Concurrently herewith	GROUP:

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A1	5,985,742	11/1999	Henley et al.	438	515	
	A2	5,994,207	11/1999	Henley et al.	438	515	
	A3	6,010,579	01/2000	Henley et al.	148	33.2	
	A4	6,013,563	01/2000	Henley et al.	438	458	
	A5	6,013,567	01/2000	Henley et al.	438	515	
	A6	6,033,974	03/2000	Henley et al.	438	526	
	A7	6,035,101	03/2000	Henley et al.	392	416	
	A8	6,048,411	04/2000	Henley et al.	148	33.5	
	A9	6,146,979	11/2000	Henley et al.	438	458	
	A10	6,155,909	12/2000	Henley et al.	451	39	
	A11	6,159,824	12/2000	Henley et al.	438	455	
	A12	6,159,825	12/2000	Henley et al.	438	460	
	A13	6,162,705	12/2000	Henley et al.	438	478	
	A14	6,187,110	03/2001	Henley et al.	148	33.2	
	A15	6,245,161	06/2001	Henley et al.	148	33.4	
	A16	6,284,631	09/2001	Henley et al.	438	526	
	A17	6,290,804	09/2001	Henley et al.	156	344	
	A18	6,291,313	09/2001	Henley et al.	438	458	
	A19	6,294,814	09/2001	Henley et al.	257	347	
	A20	6,335,264	01/2002	Henley et al.	438	460	
	A21	6,391,740	05/2002	Cheung et al.	438	455	
	A22	6,413,837	07/2002	Henley et al.	438	459	
	A23	6,458,672	10/2002	Henley et al.	438	478	
	A24	6,486,041	11/2002	Henley et al.	438	458	
	A25	6,511,899	01/2003	Henley et al.	438	515	
	A26	6,558,802	05/2003	Henley et al.	428	446	
	A27	6,528,391	03/2003	Henley et al.	438	459	
	A28	2002/0055266A1	05/2002	Henley et al.	438	737	

EXAMINER	DATE CONSIDERED
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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Sheet 2 of 2	FILING DATE:	GROUP:
	Concurrently herewith	

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A29	2002/0056519A1	05/2002	Henley et al.	156	344	
	A30	2002/0081823A1	06/2002	Cheung et al.	438	455	
	A31	2002/0106870A1	08/2002	Henley et al.	438	464	
	A32	2002/0115264A1	08/2002	Henley et al.	438	458	

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	B1	0 291 147 A1	03/1988	EPO				
	B2	1 256 973 A1	04/2001	EPO				
	B3	1 258 909 A2	05/2002	EPO				
	B4	WO 99/49501	09/1999	WIPO				
	B5	WO 01/63002 A1	08/2001	WIPO (with English abstract)			X	

OTHER REFERENCES <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>		
	C1	Lin, Chin-Teng, et al., "Temperature control of rapid thermal processing system using adaptive fuzzy network, <i>Fuzzy Sets and Systems</i> , Vol. 103, pp. 49-65 (1999)

EXAMINER	DATE CONSIDERED
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